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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Gyu-Chan JEONG et al.					Docket No. SEC.903D	
Application No. 10/702,142	Filing Date November 6, 2003	Examiner James W. Keenan	Custome 2098		Group Art Unit 3652	Confirmation No. 7811
LOAD PORT OF A SEMICONDUCTOR MANUFACTURING APPARATUS HAVING INTEGRATED KINEMATIC COUPLING PINS AND SENSORS, AND METHOD OF LOADING WAFERS USING THE SAME						
COMMISSIONER FOR PATENTS:						
	vith is an amendment in	n the above-identified a	polication.			Ī
The fee has been calculated and is transmitted as shown below.						
		CLAIMS AS AM	ENDED			
	CLAIMS REMAINING	HIGHEST #	NUMBER EXTRA			ADDITIONAL
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS PRESENT	· _	RATE	FEE
TOTAL CLAIMS	4 -	20 =	0	x	\$50.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0	×	\$200.00	\$0.00
Multiple Dependen	nt Claims (check if appl	licable)				\$0.00
		TOTAL ADDITIONAL F	FEE FOR THIS A	MENC	OMENT	\$0.00
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.						
LINUS Y. PARK Reg. No. 45,261 Volentine Francos & Whitt, P.L.L.C. One Freedom Squure 11951 Freedom Drive, Suite 1260 Reston, VA 20190 Tel. No. 571-283-0720 I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date)						
cc:		Signature of Person Mailing Correspondence Typed or Printed Name of Person Mailing Correspondence				
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Application No. 10/702,142 SEC.903D Amendment dated April 27, 2005l

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Gyu-Chan JEONG et al.

: Group Art Unit: 3652

Serial No.: 10/702,142

: Examiner: James W. Keenan

Filed: November 6, 2003

LOAD PORT OF A SEMICONDUCTOR MANUFACTURING APPARATUS HAVING INTEGRATED KINEMATIC COUPLING PINS AND SENSORS, AND METHOD OF LOADING WAFERS USING THE SAME

AMENDMENT AND REQUEST FOR RECONSIDERATION

U.S. Patent and Trademark Office **Customer Window, Mail Stop Amendment** Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Office Action dated February 03, 2004, the Applicants submit the following amendments, remarks and arguments regarding the above-identified application as follows:

Amendments to the Specification begin on page 2 of the paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 3 of this paper.